

## WEST Search History





DATE: Wednesday, September 01, 2004

<u>Hide?</u>	<u>Set Name</u>	<u>Query</u>	<u>Hit Count</u>
<i>DB=PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD; PLUR=YES; OP=OR</i>			
<input type="checkbox"/>	L14	L13 and (reactor or chamber)	1783
<input type="checkbox"/>	L13	ONO and plasma	5615
<input type="checkbox"/>	L12	L9 and (deposit\$4 with onto with nitride)	0
<input type="checkbox"/>	L11	L9 and (deposit\$4 with on with nitride)	0
<input type="checkbox"/>	L10	L9 and (deposition adj chamber)	379
<input type="checkbox"/>	L9	plasma and (deposit\$4 with (direct\$4 or contact\$4) with nitride)	3156
<input type="checkbox"/>	L8	plasma and (deposit\$4 with (direct\$4 or contact\$4) with nitride)	3156
<i>DB=USPT; PLUR=YES; OP=OR</i>			
<input type="checkbox"/>	L7	L6 and (deposition adj chamber)	368
<input type="checkbox"/>	L6	(plasma with nitride) and (plasma with oxide)	5771
<input type="checkbox"/>	L5	L4 and 0.6	26
<input type="checkbox"/>	L4	(oxidation adj rate) same nitride	272
<input type="checkbox"/>	L3	L2	0
<input type="checkbox"/>	L2	(wet adj RTO) same rate same nitride	0
<input type="checkbox"/>	L1	(wet adj RTO) same rate same nitride same silicon	0

END OF SEARCH HISTORY